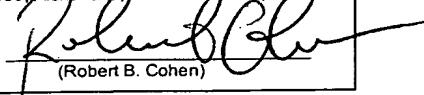




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Docket No.: SCEI 3.0-124
(PATENT)

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hitoshi Ebihara

Application No.: 10/085,587

Group Art Unit: 2676

Filed: February 27, 2002

Examiner: Po Wei Chen

For: INFORMATION PROCESSING SYSTEM,
INTEGRATED INFORMATION PROCESSING
SYSTEM, METHOD FOR CALCULATING
EXECUTION LOAD, AND COMPUTER
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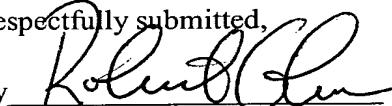
CERTIFICATION PURSUANT TO 37 C.F.R. § 1.97(E)(1)

Dear Sir:

Pursuant to 37 C.F.R. § 1.97(e) (1), undersigned counsel hereby certifies that each item of information contained in the accompanying Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application to the above-referenced patent application not more than three months prior to the filing of said statement.

Dated: January 12, 2004

Respectfully submitted,

By 

Robert B. Cohen

Registration No.: 32,768

LERNER, DAVID, LITTMERBERG,
KRUMHOLZ & MENTLIK, LLP

600 South Avenue West
Westfield, New Jersey 07090

(908) 654-5000

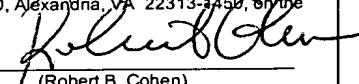
Attorney for Applicant

LD-456

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Dated: January 12, 2004 Signature: 

(Robert B. Cohen)

Docket No.: SCEI 3.0-124
(PATENT)

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In re Patent Application of:
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INFORMATION DISCLOSURE STATEMENT

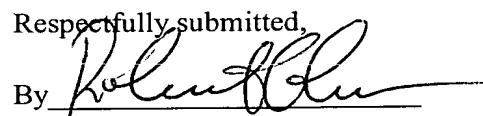
Dear Sir:

It is respectfully requested that the references listed on the enclosed form be made of record and considered with respect to the above-referenced U.S. patent application. The listed references were cited in an Official Action issued in connection with applicant's corresponding Japanese patent application. A copy of the Official Action (and an English translation thereof), and a copy of each reference are enclosed. Submission of the present Information Disclosure Statement should not be taken as an admission that the cited references are legally available prior art or that the same are pertinent or material.

In the event that any fee is due in connection with the present Information Disclosure Statement, the Commissioner is hereby authorized to charge the same to our Deposit Account No. 12-1095.

Dated: January 12, 2004

Respectfully submitted,

By 
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Attorney for Applicant

LD-458\

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Substitute for form 1449A/B/PTO				<i>Complete if Known</i>	
				Application Number	10/085,587
				Filing Date	February 27, 2002
				First Named Inventor	Hitoshi Ebihara
				Art Unit	2676
				Examiner Name	P. W. Chen
Sheet	1	of	1	Attorney Docket Number	SCEI 3.0-124
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)			
BA	JP-59-116864-A1	07-05-1984	Fujitsu Ltd		**
BB	JP-02-300947-A1	12-13-1990	Fujitsu Ltd		**
BC	JP-63-170702-A1	07-14-1988	Yokogawa Electric Corp		**
BD	JP-05-035889-A1	02-12-1993	NEC Corp		**
BE	JP-07-044423-A1	02-14-1995	Sony Corp		**
BF	JP-09-073405-A1	03-18-1997	Hitachi Ltd		**
BG	JP-05-002508-A1	01-08-1993	Fujitsu Ltd		**
BH	JP-55-063450-A1	05-13-1980	Hitachi Ltd		**
BI	JP-59-105157-A1	06-18-1984	Casio Comput Co Ltd		**
BJ	JP-08-211906-A1	08-20-1996	Toshiba Corp		**
BK	JP-10-240700-A1	09-11-1998	Hitachi Ltd		**

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